



GR 2813

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Docket No.: M4065.0227/P227  
(PATENT)

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
TECHNOLOGY CENTER 2800

In re Patent Application of:  
Tongbi Jiang, et al.

Application No.: 09/652,216

Group Art Unit: 2813

Filed: August 30, 2000

Examiner: E. Pert

For: METHOD AND APPARATUS FOR  
REDUCING SUBSTRATE BIAS VOLTAGE  
DROP

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents  
Washington, DC 20231

Dear Sir:

In response to the restriction requirement mailed October 18, 2001, applicant hereby elects claims 1-30 and 66-99 for continued examination, without traverse.

Applicant solicits issuance of claims 1-30 and 66-99.

Dated: November 7, 2001

Respectfully submitted,

By

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